

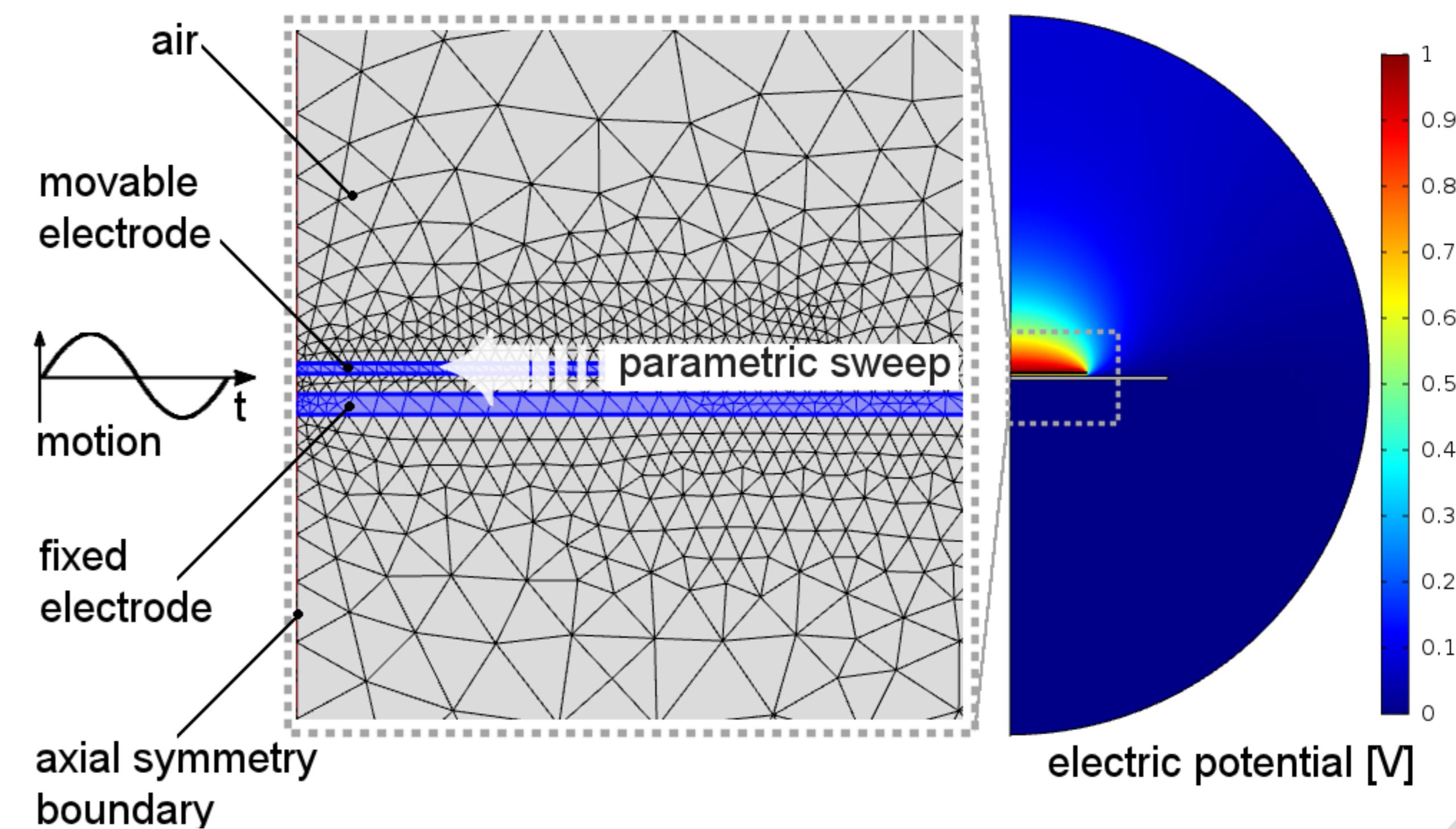
Analysis of Geometrical Aspects of a Kelvin Probe

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Introduction:

- A kelvin probe is a non-contact, non-destructive measurement technique to investigate the work function difference of materials.
- It is based on a time varying capacitor where the movable electrode consists of a material and a fixed electrode of a second material with different work functions. For electrically connected electrodes the Fermi levels are equilibrated by electrons flowing. Consequently, a contact potential difference establishes and the capacitor is charged.
- The vibration of the movable electrode results in a change of the stored electrical energy within the capacitor forcing an electrical current to flow.

Figure: 2D axial symmetric model setup of the kelvin probe.



Transient behavior of kelvin probe:

- COMSOL (AC/DC, MEMS)
- Use of Electromechanics Interface:

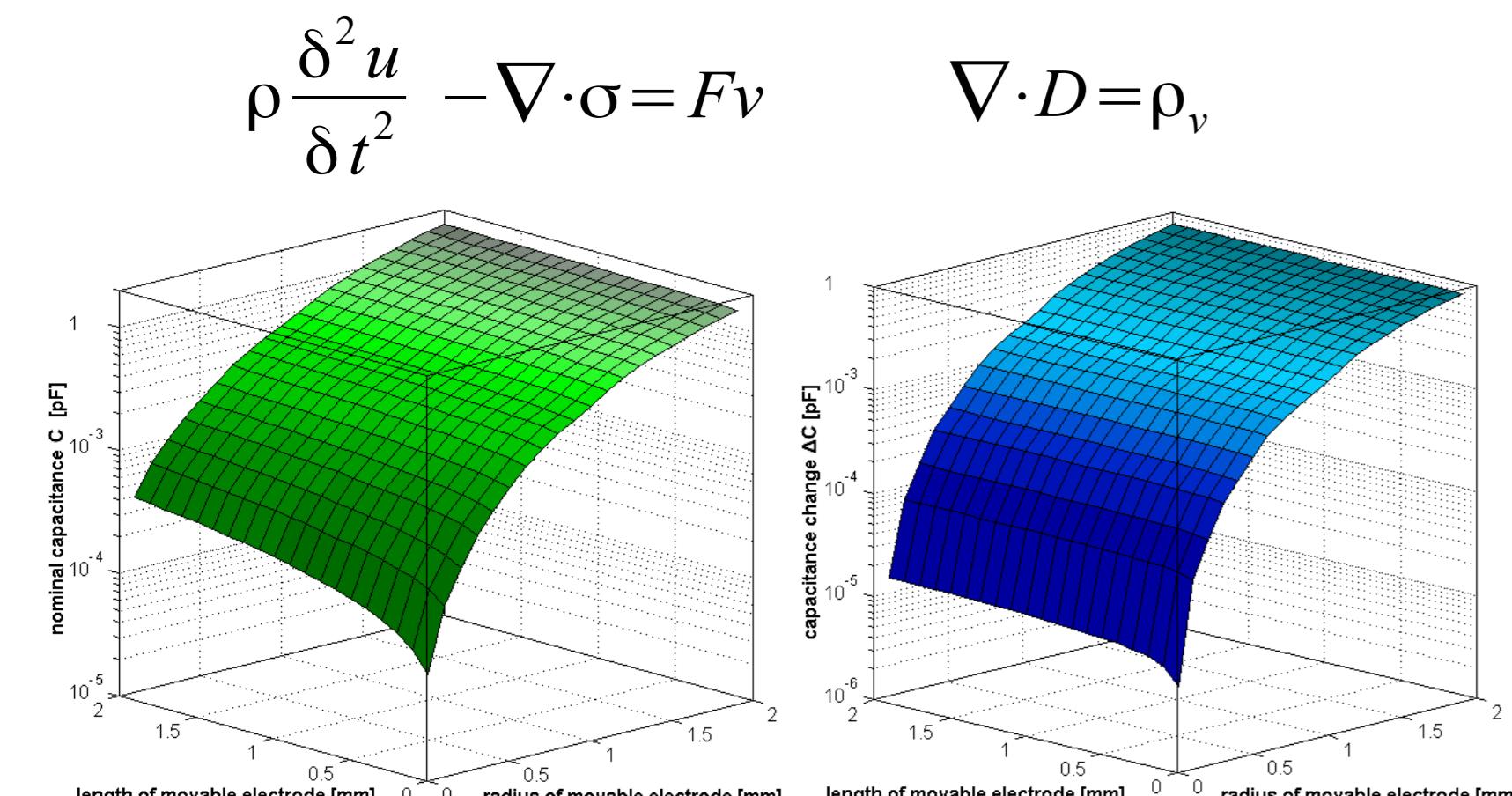


Figure: Left: The nominal capacitance, right: The capacitance change – as functions of length and radius.

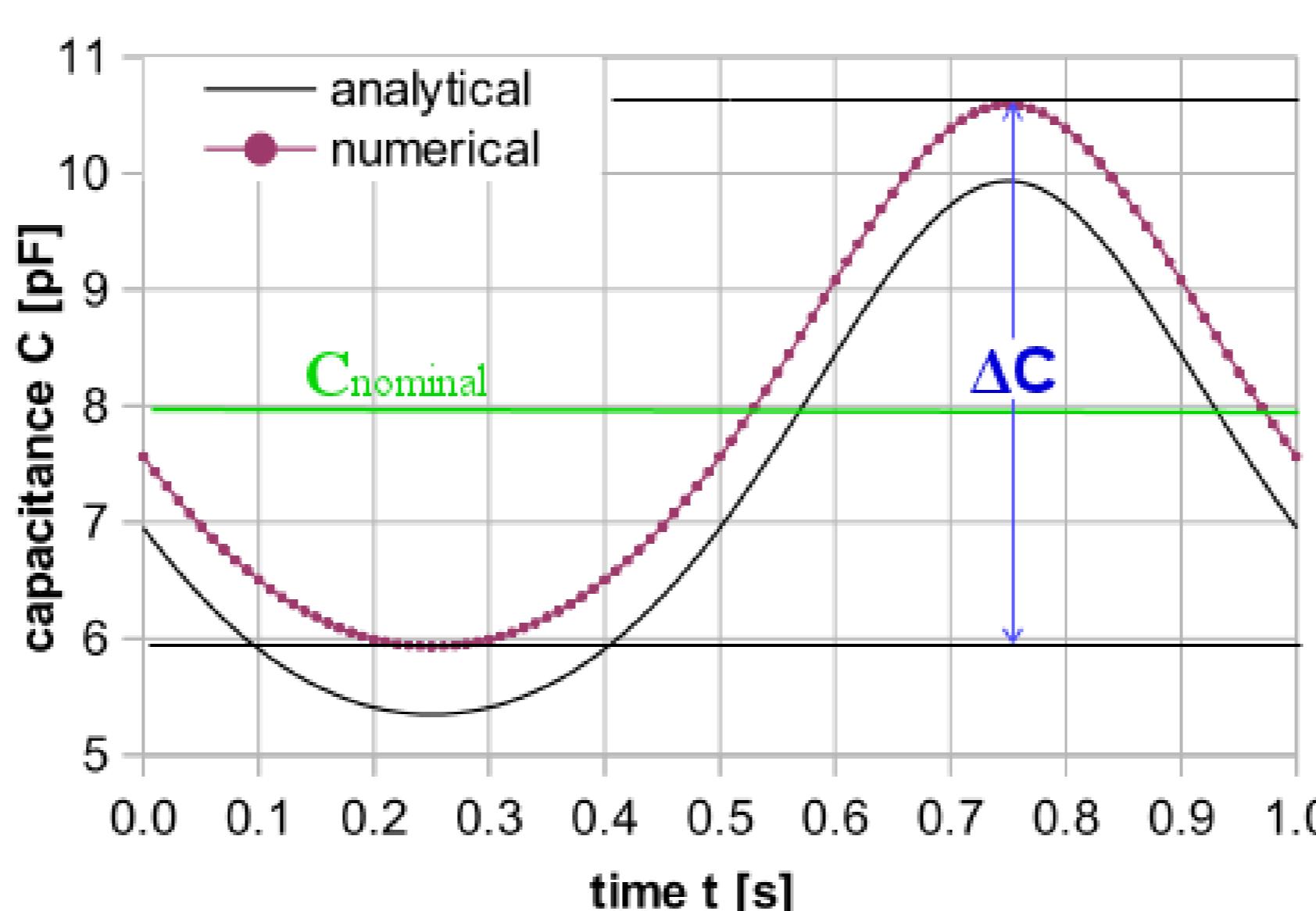


Figure: Characteristic transient capacitance behavior of the kelvin probe.

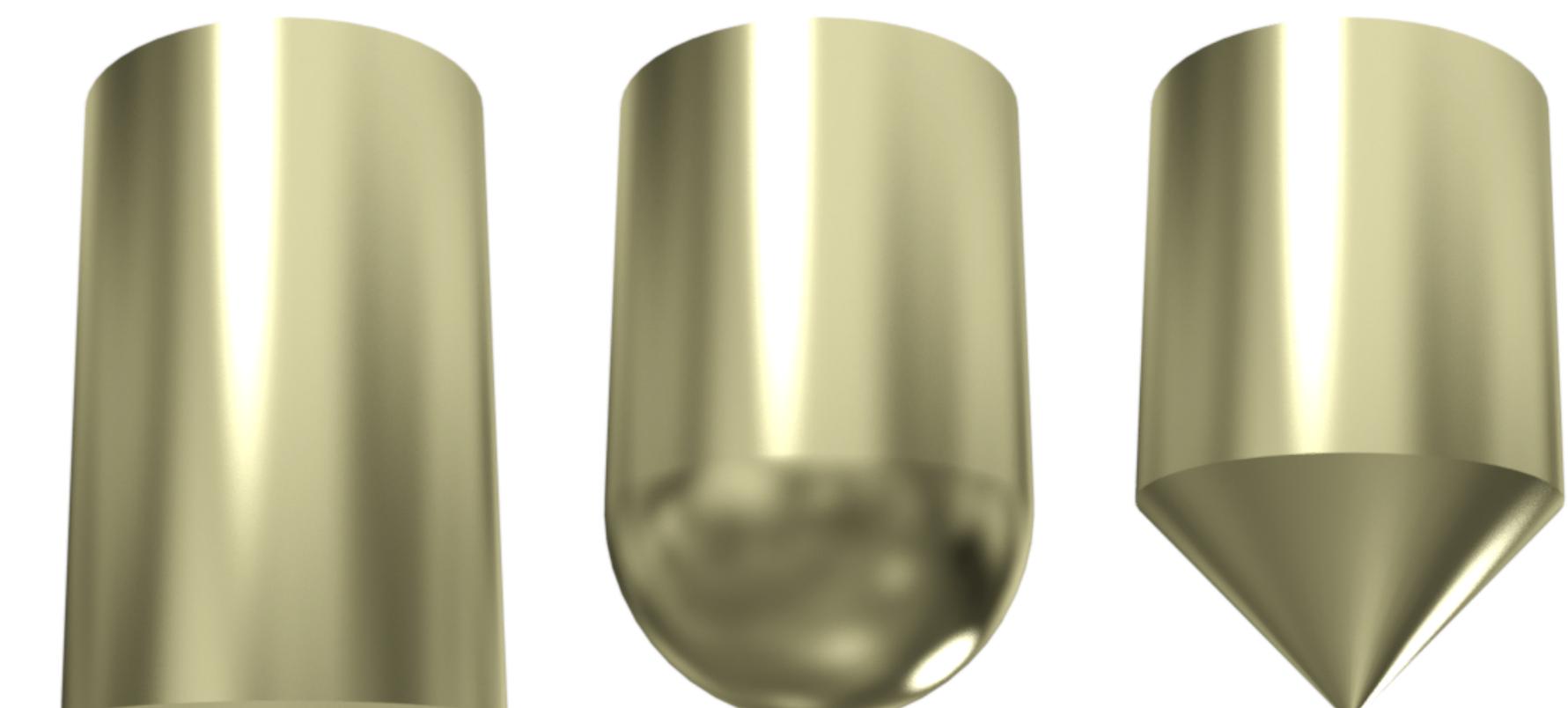


Figure: Tips: flat tip, round tip, spikey tip (45°).

Tip geometries of klevin probe

- Investigation of different probe tips: flat, round, spikey (45°)
- Shrinking of tip radius between 2mm to 50μm

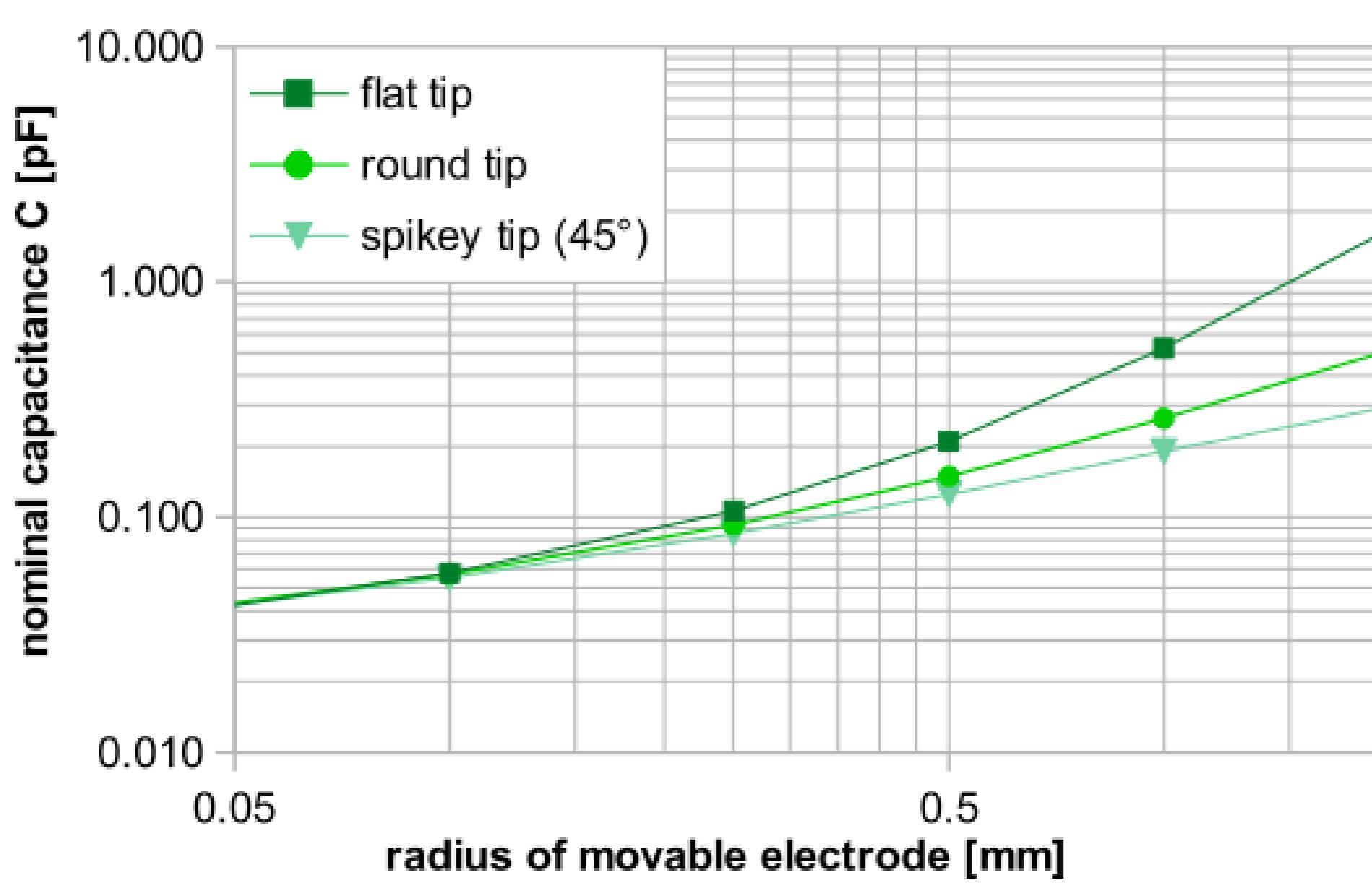


Figure: Nominal capacitance of different tips.

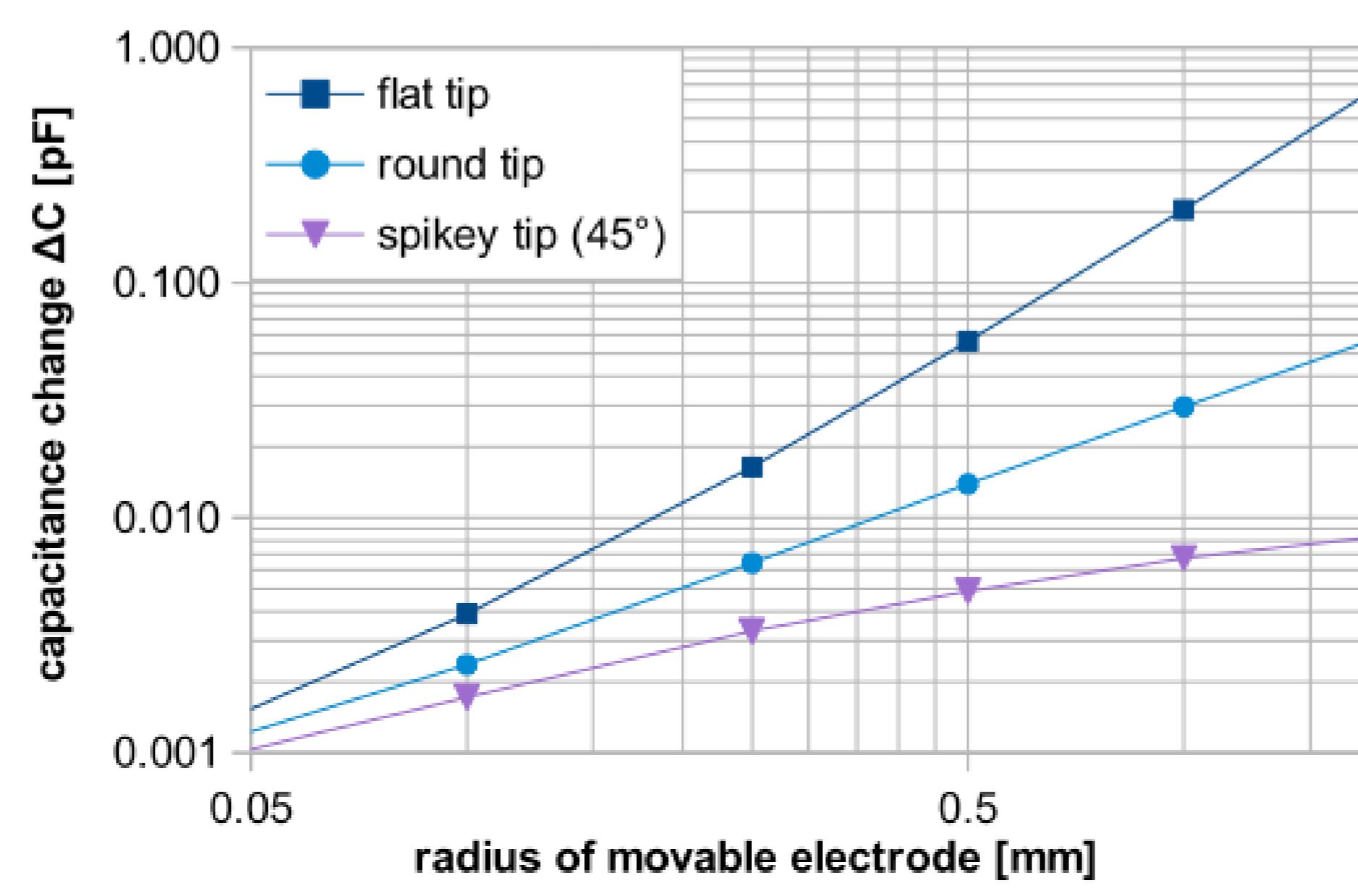


Figure: Capacitance change of different tips.

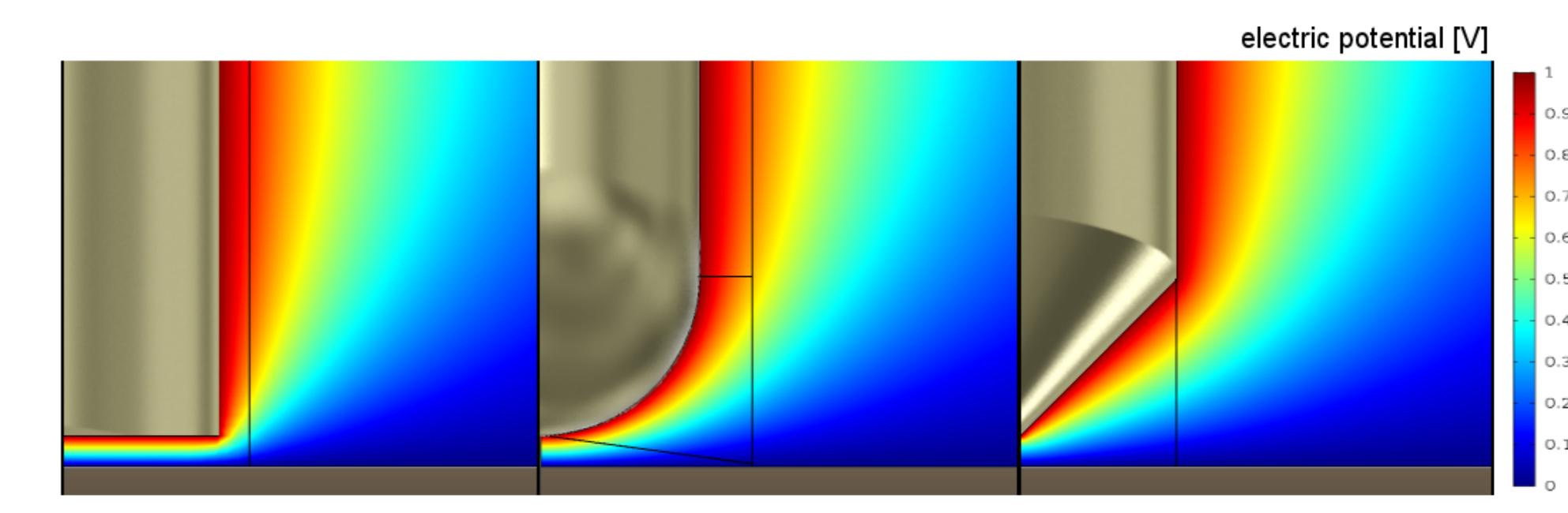


Figure: Electric potential of three different tips: flat tip, round tip, spikey tip (45°).

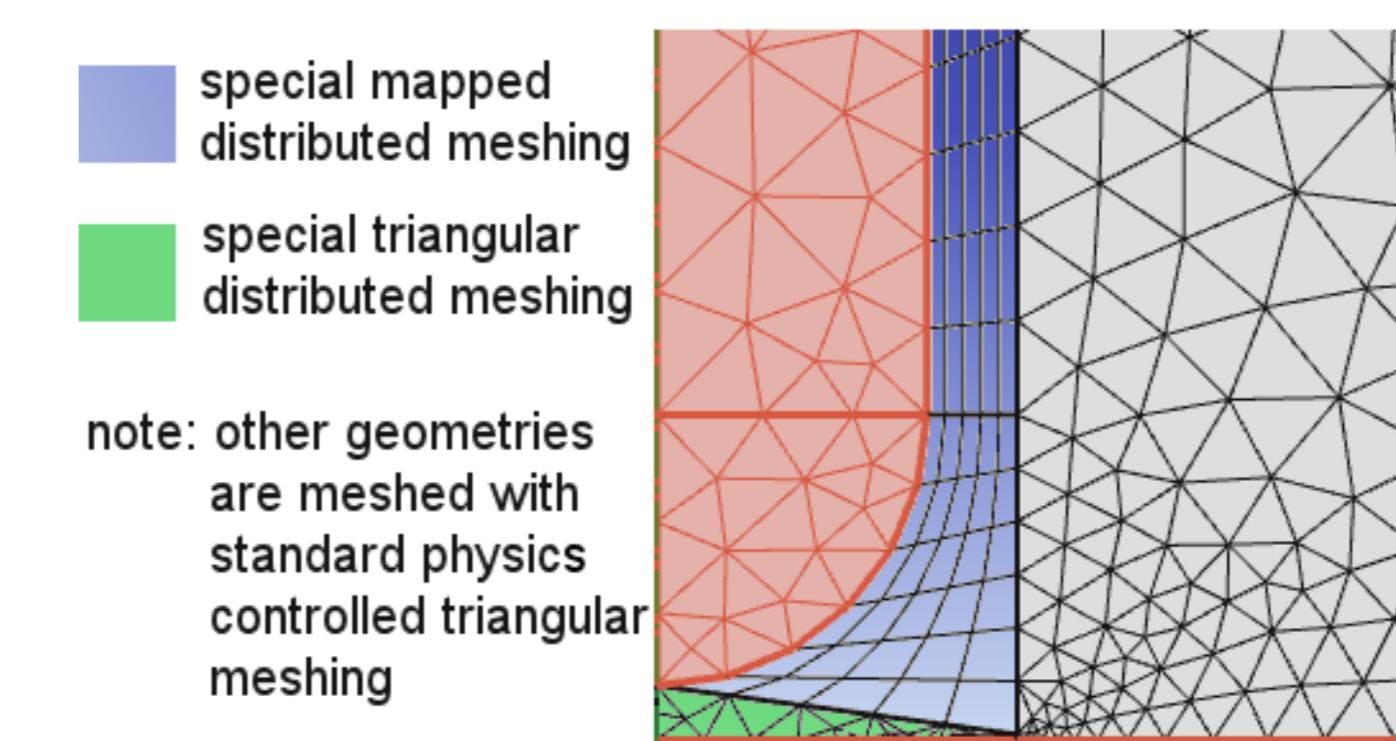


Figure: Additional airspace meshing of the round tip model.

Equivalent electrical circuit of kelvin probe:

- Use of Electric Circuit Interface
- Simple electrical measurement circuit: Load Resistor
- Comparison:
COMSOL vs. **Spice**

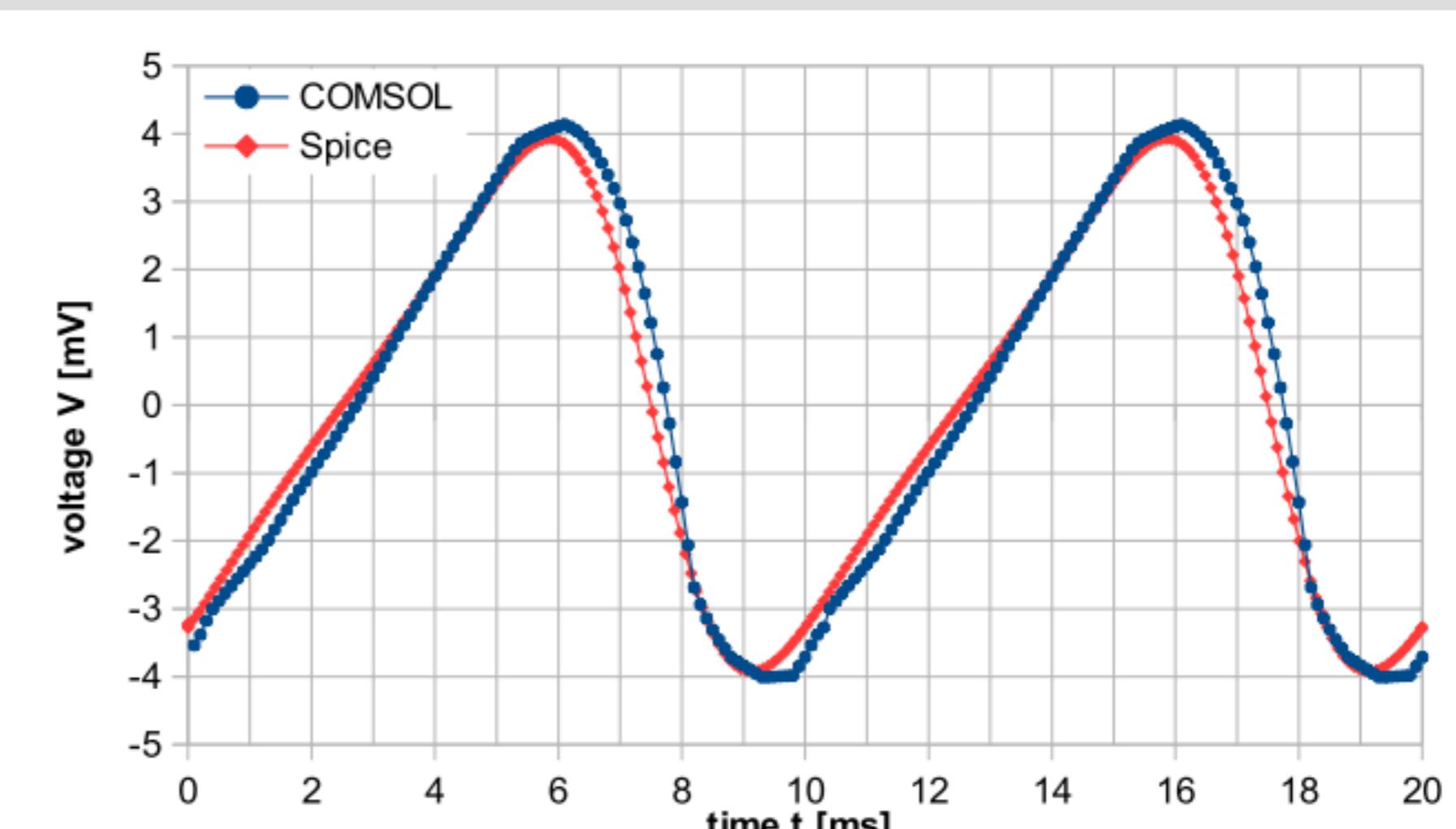
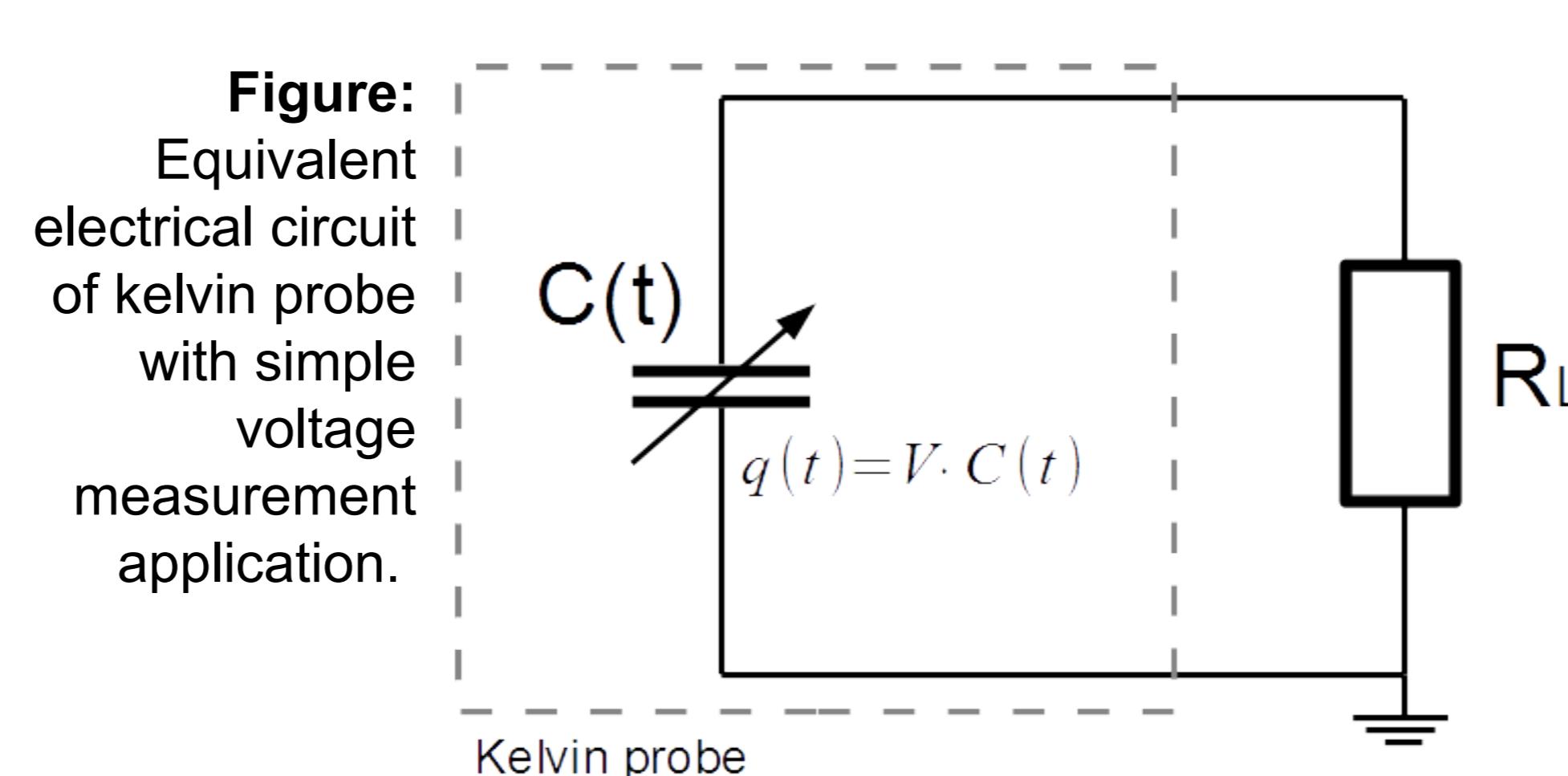


Figure: Characteristic transient voltage drop over load resistor.

Conclusion: A COMSOL model of a kelvin probe was successfully established and different probe geometries were investigated. Moreover, the model was expanded by a simple electrical measurement circuitry to demonstrate a complete kelvin probe setup.

References:

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